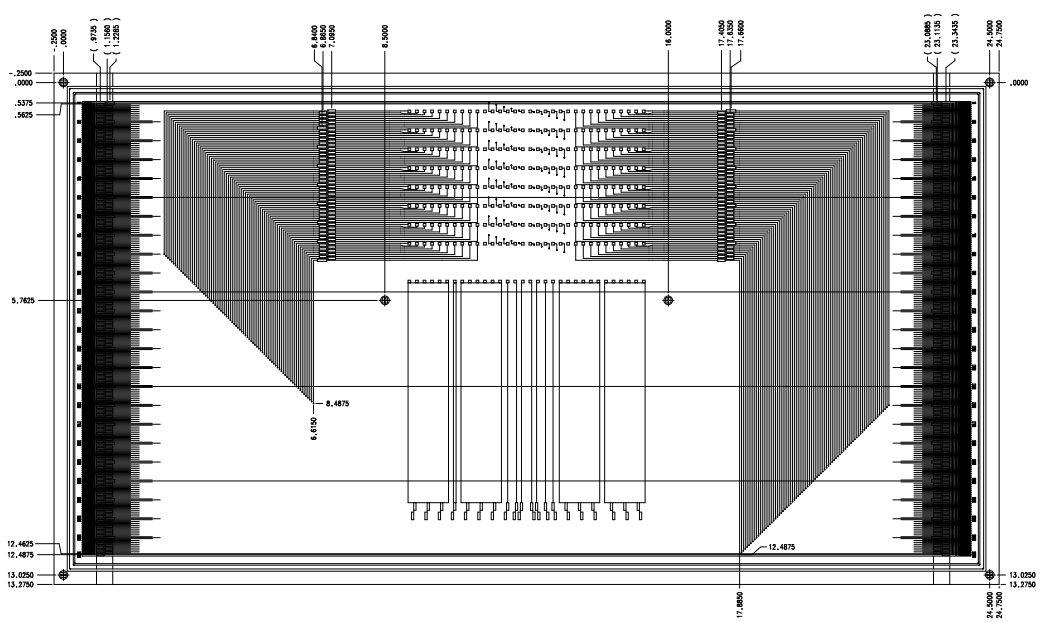

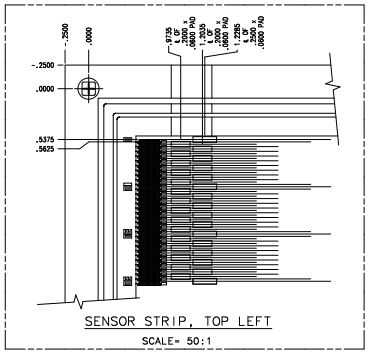

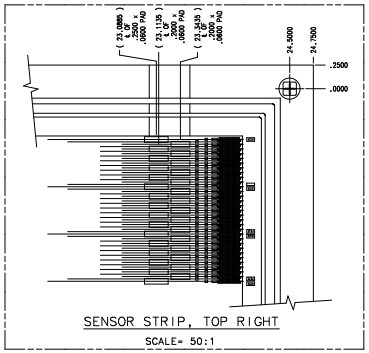

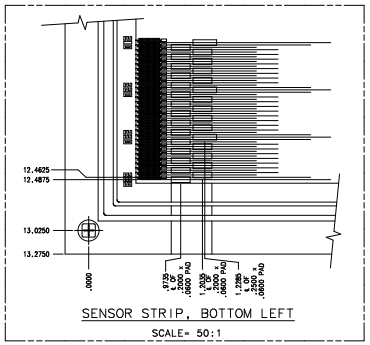

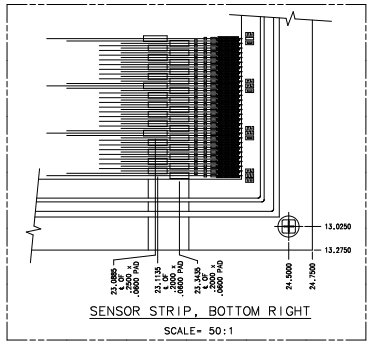

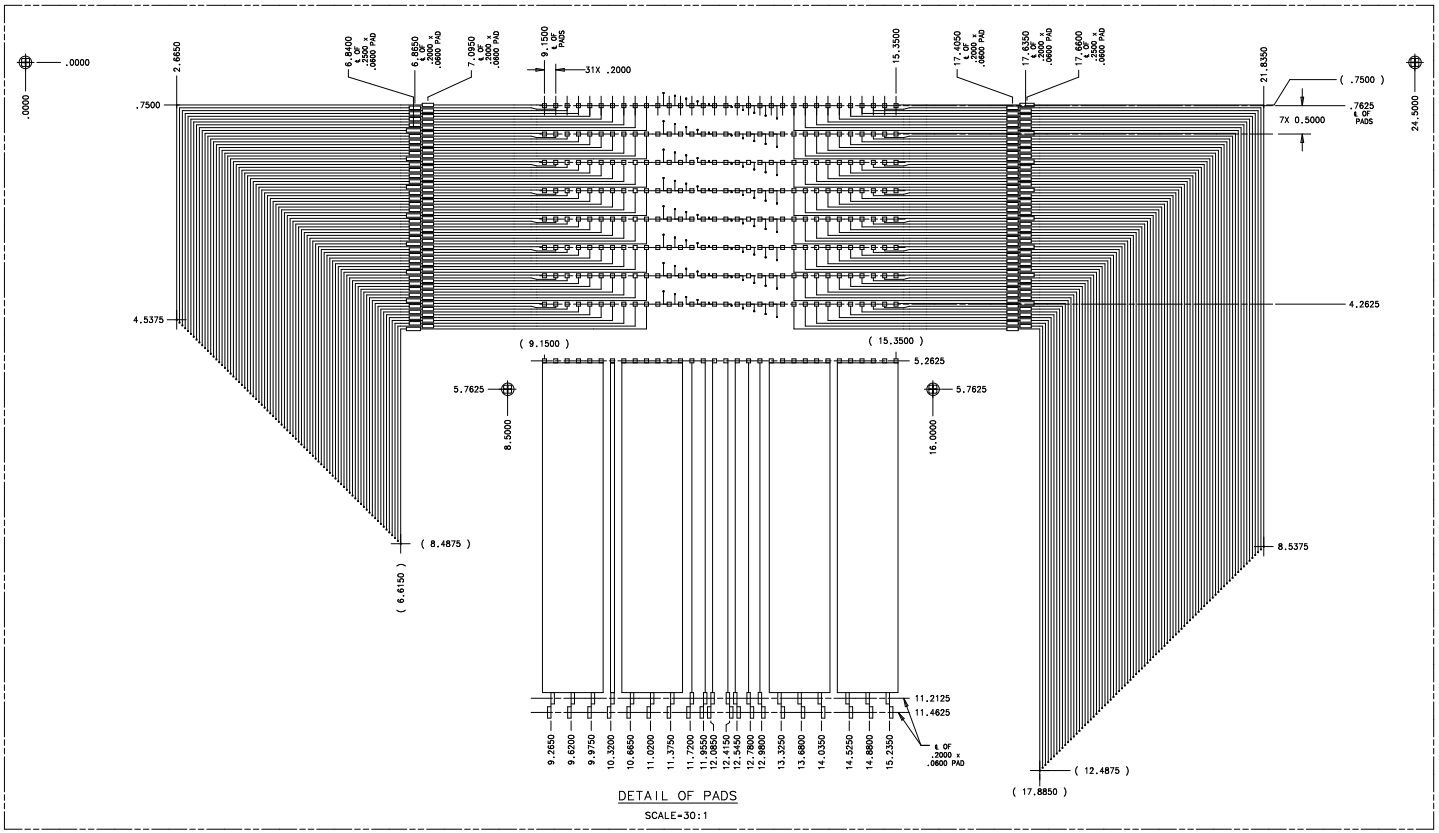

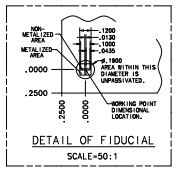

NOTE

SENSOR LINES HAVE BEEN TRUNCATED FOR CLARITY OF ILLUSTRATION ONLY. SENSOR LINES EXTEND CONTINUOUSLY FROM LEFT TO RIGHT.

UNLESS OTHERWISE SPECIFIED	ORIGINATOR	T.NELSON	10-JUL-2007
.XXX ± .010 .XXXX ± .001 ANGLES ± ---	DRAWN	P.POLL	03-AUG-2007
	CHECKED		
1. BREAK ALL SHARP EDGES MAX.	APPROVED		
2. DO NOT SCALE DRAWING.	USED ON		
3. DIMENSIONING AND TOLERANCING PER ASME Y14.5M-1994			
4. MAX. ALL MACH. SURFACES	MATERIAL	SILICON	
5. DRAWING UNITS: METRIC			

FERMI NATIONAL ACCELERATOR LABORATORY
UNITED STATES DEPARTMENT OF ENERGY

ILC EXPERIMENTS GENERAL SID SILICON DETECTOR KPIX TEST STRUCTURE

SCALE	DRAWING NUMBER	SHEET	REV
NO ↑ & NOTED	4901.000-ME-457383	1 OF 1	

CREATED WITH : Ideas12NXSeries | GROUP: PPD/MECHANICAL DEPARTMENT